

|   | Type | L # | Hits | Search Text  | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|---|------|-----|------|--|---|---------------------|----------|------------------|--------|
| 1 | BRS  | L1  | 7    | ("118"/\$).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>and (substrate<br>or wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve and<br>buffer near<br>tank | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:41 |          |                  |        |

|   | Type | L # | Hits | Search Text  | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|---|------|-----|------|--|---|---------------------|----------|------------------|--------|
| 2 | BRS  | L2  | 2    | ("427"/\$).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>and (substrate<br>or wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve and<br>buffer near<br>tank | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:49 |          |                  |        |

|   | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|---|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 3 | BRS  | L3  | 13   | (427/240).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:44 |          |                  |        |

|   | Type | L # | Hits | Search Text  | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|---|------|-----|------|--|---|---------------------|----------|------------------|--------|
| 4 | BRS  | L5  | 7    | ("118"/\$).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>and (substrate<br>or wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve and<br>buffer near<br>tank | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:43 |          |                  |        |

|   | Type | L # | Hits | Search Text  | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|---|------|-----|------|--|---|---------------------|----------|------------------|--------|
| 5 | BRS  | L6  | 49   | ("118"/\$).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:48 |          |                  |        |

|   | Type | L # | Hits | Search Text  | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|---|------|-----|------|--|---|---------------------|----------|------------------|--------|
| 6 | BRS  | L7  | 14   | (118/52).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:44 |          |                  |        |

|   | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|---|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 7 | BRS  | L8  | 2    | (118/683).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:45 |          |                  |        |

|   | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Com<br>men<br>ts | Er<br>ro<br>r<br>De<br>fi<br>ni<br>ti<br>on | Er<br>ro<br>rs |
|---|------|-----|------|---|---|---------------------|------------------|---|----------------|
| 8 | BRS  | L9  | 4    | (118/684).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:45 |                  |   |                |



|   | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|---|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 9 | BRS  | L10 | 1    | (118/712).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:45 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 10 | BRS  | L11 | 12   | (118/320).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:45 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 11 | BRS  | L12 | 2    | (118/688).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:46 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 12 | BRS  | L13 | 1    | (118/689).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:46 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 13 | BRS  | L14 | 0    | (118/690).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:46 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Com<br>mm<br>en<br>ts | Er<br>ro<br>r<br>De<br>fi<br>ni<br>ti<br>on | Er<br>ro<br>rs |
|----|------|-----|------|---|---|---------------------|-----------------------|---|----------------|
| 14 | BRS  | L15 | 0    | (118/691).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:46 |                       |   |                |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 15 | BRS  | L16 | 4    | (118/692).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:46 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 16 | BRS  | L17 | 2    | (118/693).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:46 |          |                  |        |



|    | Type | L # | Hits | Search Text  | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|--|---|---------------------|----------|------------------|--------|
| 17 | BRS  | L19 | 39   | ("438"/\$).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:47 |          |                  |        |

|    | Type | L # | Hits | Search Text  | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|--|---|---------------------|----------|------------------|--------|
| 18 | BRS  | L20 | 2    | ("438"/\$).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>and (substrate<br>or wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve and<br>buffer near<br>tank | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:47 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 19 | BRS  | L21 | 2    | (438/780).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>and (substrate<br>or wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve and<br>buffer near<br>tank | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:47 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Co<br>mm<br>en<br>ts | Er<br>ro<br>r<br>De<br>fi<br>ni<br>ti<br>on | Er<br>ro<br>rs |
|----|------|-----|------|---|---|---------------------|----------------------|---|----------------|
| 20 | BRS  | L22 | 0    | (438/781).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>and (substrate<br>or wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve and<br>buffer near<br>tank | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:48 |                      |   |                |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 21 | BRS  | L23 | 1    | (438/758).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>and (substrate<br>or wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve and<br>buffer near<br>tank | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:48 |          |                  |        |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Co<br>mm<br>en<br>ts | Er<br>ro<br>r<br>De<br>fi<br>ni<br>ti<br>on | Er<br>ro<br>rs |
|----|------|-----|------|---|---|---------------------|----------------------|---|----------------|
| 22 | BRS  | L24 | 0    | (438/689).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>and (substrate<br>or wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve and<br>buffer near<br>tank | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:48 |                      |   |                |

|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 23 | BRS  | L26 | 1    | ((coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank).clm. | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:49 |          |                  |        |

|    | Type | L # | Hits | Search Text  | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|--|---|---------------------|----------|------------------|--------|
| 24 | BRS  | L25 | 2    | ((coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve).clm. | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:49 |          |                  |        |



|    | Type | L # | Hits | Search Text   | DBs   | Time Stamp          | Comments | Error Definition | Errors |
|----|------|-----|------|---|---|---------------------|----------|------------------|--------|
| 25 | BRS  | L18 | 3    | (118/694).ccls.<br>and (coat\$6 or<br>spray\$4 or<br>spin\$4 adj<br>coat\$4) with<br>(substrate or<br>wafer) and pump<br>with tank and<br>(substrate or<br>wafer) with<br>(spin\$4 or<br>rotat\$4) and<br>(fluid or<br>liquid) with<br>(sens\$4 or<br>detect\$5) and<br>valve | US-PGPUB;<br>USPAT; EPO;<br>JPO;<br>DERWENT;<br>IBM_TDB | 2006/02/16<br>17:49 |          |                  |        |